

Form PTO-1449

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

ATTY. DOCKET NO.
0171-1061PAPPLICATION NO.
NEWAPPLICANT
HARADA, Yuji et alFILING DATE
February 9, 2004

GROUP

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	Kind	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
RA	US 4,491,628		1985-01-01	Ito et al.			
ED	US 5,310,619	A	1994-05-10	Crivello et al.			
	US						
	US						
	US						
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	US						
	US						

FOREIGN PATENT DOCUMENTS

	Office	DOCUMENT NUMBER	Kind	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION	
								YES	NO
WA	JP	2-27660 ✓	B2	1990-06-19	JAPAN			ABS	
PA	JP	63-27829 ✓	A	1988-02-05	JAPAN			ABS	
WA	JP	9-73173 ✓	A	1997-03-18	JAPAN			ABS	
WA	JP	10-10739 ✓	A	1998-01-16	JAPAN			ABS	
WA	JP	9-230595 ✓	A	1997-09-05	JAPAN			ABS	
WA	WO	97/33198 ✓	A1	1997-09-12	WO			ABS	
WA	JP	2001-146505	A	2001-05-29	JAPAN			ABS	

OTHER DOCUMENTS

(Include Name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.

WA Hiroshi, Ito et al., "Polymer design for 157 nm chemically amplified resists", SPIE 2001, Proceedings 4345-31, Pages 273-285

EXAMINER

P. Ashton

DATE CONSIDERED

10-17-04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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